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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): NAKANO, et al
Serial No.: 10/075,244
Filed: February 15, 2002
For: METHOD AND APPARATUS FOR PLASMA PROCESSING
Group: 1762
Examiner: M. Padgett

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 14, 2003

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application in response to the Office Action dated June 12, 2003.